

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.
Applicant
Filed
Title



10/722,758
Masaki Tamaru et al.
November 26, 2003
SEMICONDUCTOR DEVICE AND METHOD OF
MANUFACTURING THE SAME UTILIZING PERMITTIVITY
OF AN INSULATING LAYER TO PROVIDE A DESIRED
CROSS CONDUCTIVE LAYER CAPACITANCE PROPERTY

Conf. No. : 7196
TC/A.U. : 2811
Examiner : Hung K. Vu

Customer No. : 000,116
Docket No. : 32811US1

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

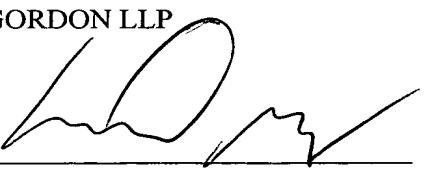
In accordance with 37 C.F.R. 1.97 and 1.98, Applicant is submitting herewith Form PTO-1449 listing references for consideration by the Examiner. Also submitted herewith is a legible copy of each reference, as well as a copy of a Japanese Office Action (English language translation attached).

Enclosed is a check in the amount of \$180.00 under 37 CFR 1.117(p). If there are any additional fees associated with this communication, please charge said fees to Deposit Account No. 16-0820, Order No. 32811US1.

Respectfully submitted,

PEARNE & GORDON LLP

By:


Michael W. Garvey, Reg. No. 35878

03/03/2005 HGUTEMA1 00000044 10722758

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180.00 OP

1801 East 9th Street
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Date: February 28, 2005

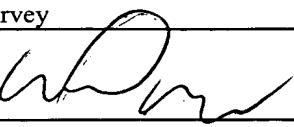
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Mail Stop Amendment, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Michael W. Garvey

Name of Attorney for Applicant(s)

February 28, 2005

Date


Signature of Attorney

INFORMATION DISCLOSURE CITATION
BY APPLICANT
(USE SEVERAL SHEETS IF NECESSARY)

Page 1 of 1

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APPLICANT:
Masaki Tamari et al.FILING DATE:
November 26, 2003GROUP ART UNIT:
2811

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass	Filing Date
	A						
	B						
	C						
	D						
	E						
	F						
	G						
	H						
	I						
	J						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subclass	Translation
	K	7-161932	6/1995	JP			No/Cited in JP Office action
	L	10-65101	3/1998	JP			No/Cited in JP Office action
	M	2-33966	2/1990	JP			No/Cited in JP Office action
	N	61-226949	10/1986	JP			No/Cited in JP Office action
	O	3-293775	12/1991	JP			No/Cited in JP Office action
	P						

OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)

Q

Examiner:

Date Considered

*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.